# Study of surface cleaning and Cs-activation on GaN photocathodes



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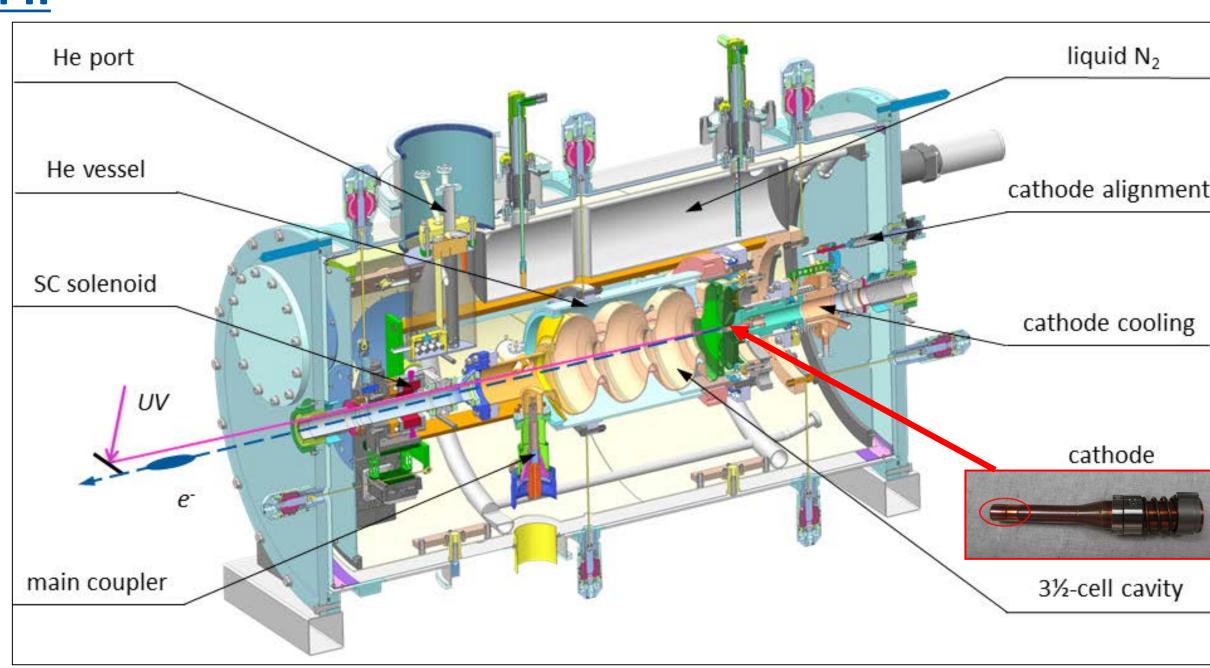


generated electrons

N incident photons

### 1. Introduction

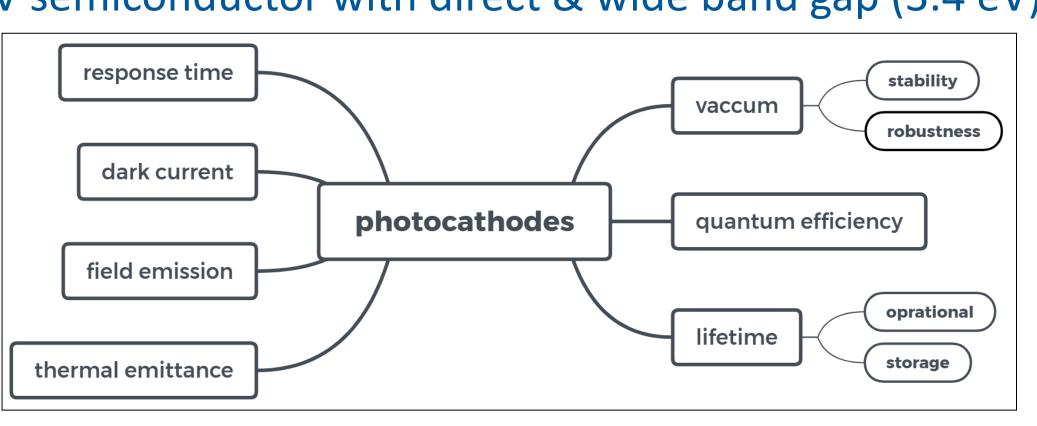
#### **SRF Gun II**



scheme of SRF gun II

### desireable requirements for photocathodes

- searching for better photocathodes is one of the principle challenges for photoinjectors
- average current up to several mA is desireable
- novel III-V semiconductor with direct & wide band gap (3.4 eV)

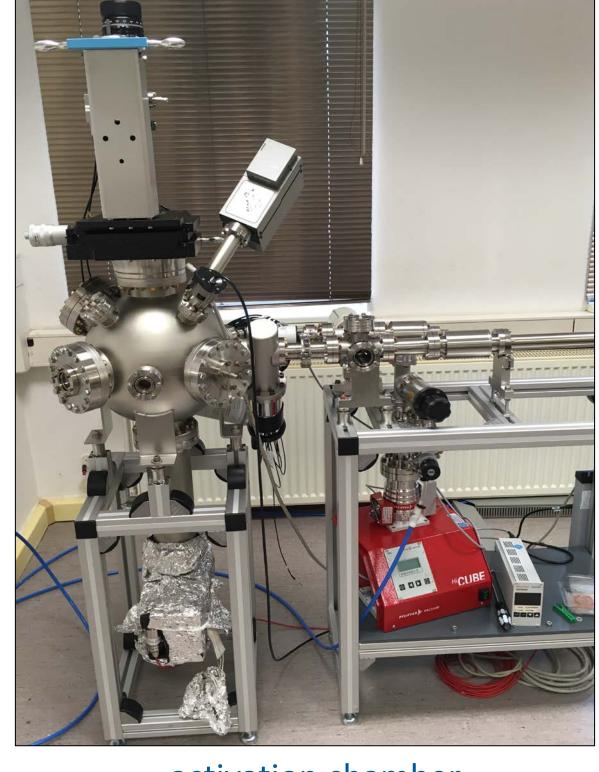


requirements for photocathodes used in accelerators

## 4. Ongoing working plan

#### analytical chemistry

- SEM, TEM & AFM
- XRD, XPS & EDX
- RBS & AES
- PL & QE
- cleaning process of GaN wafer? (analytical surface chemistry)
- comparison of GaN on different substrate material
- Cs-activation processing
- chemical stability under intensive laser?
- processing in SRF Gun II?



inside view in activation chamber

activation chamber

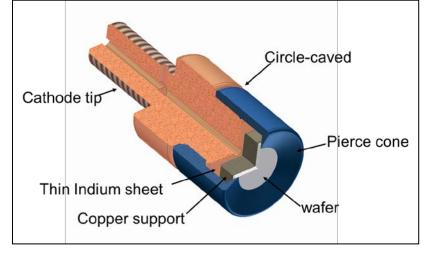
#### Modification of activation chamber

#### combination with SEM/EDX

- easy measurement of activated GaN
- detect contaminations/ lattice impurities

#### sample changement

- easy handling
- transfer from glove box without air exposure



scheme of wafer holder



cathode (cathode body + plug)

### 2. GaN (Cs)

#### **GaN** properties

high QE (~40%)

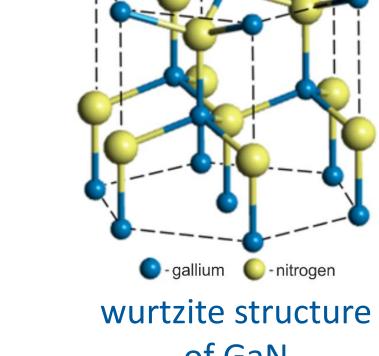
Eg= 3.4 eV

**GaN** 

photocathode

R&D

- working wavelength range of 150 nm- 400 nm
- negative electron affinity (NEA)  $\rightarrow$  with Cs
- high robustness: resitant to vacuum contaminations
- good storage: ~3 years under nitrogen atmosphere



of GaN

### cesium activation & NEA

- Mg doping is necessary
  - → increases diffusion length of e<sup>-</sup> to surface
- activation with monolayer of Cs
  - > work function near surface is lowered below vacuum level (NEA)
- [S. Uchiyama., et al., APL 86, 103511 (2005)]

#### **Table 1: Comparison of different photocathodes (for SRF Guns)**

Property [Unit]	K <sub>2</sub> CsSb	Cs <sub>2</sub> Te	GaAs	Cu	Mg	GaN
harmonic *	2	4	2	4	4	3
λ [nm]	532	266	532	266	266	365
QE [%]	8	5	5	1.4E-2	0.5	~40
lifetime [hours]	4	> 100	~58	> 1 year	> 1 year	several years
response time [ps]	prompt	prompt	< 40	prompt	prompt	???
vacuum tolerance	poor	very good	poor	excellent	excellent	excellent

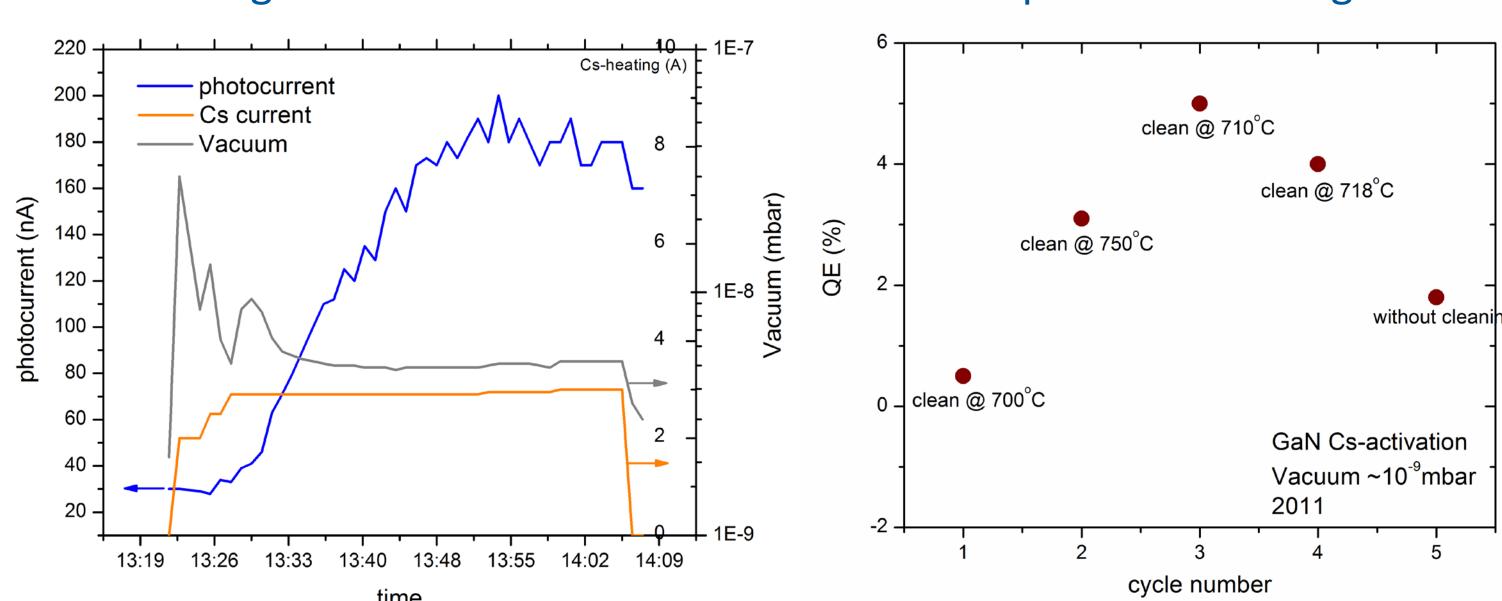
\* For drive laser: Nd:YAG, output at 1064 nm

Introduction to the physics of electron emission, K.L.Jensen, 2017, p. 444 f. Bazarov, Ivan V. et al. 2009. "Thermal Emittance and Response Time Measurements of a GaN Photocathode." Journal of Applied Physics 105(8).

### 3. First activation treatments

sample of 10<sup>17</sup>-level p-doped GaN grown on silicon substrate

- pre-heat treatment to remove absorbed residual gases on GaN surface
- activated with Cs-dispenser (SAES) to achieve the NEA surface
- background vacuum in the test chamber droped down during activation

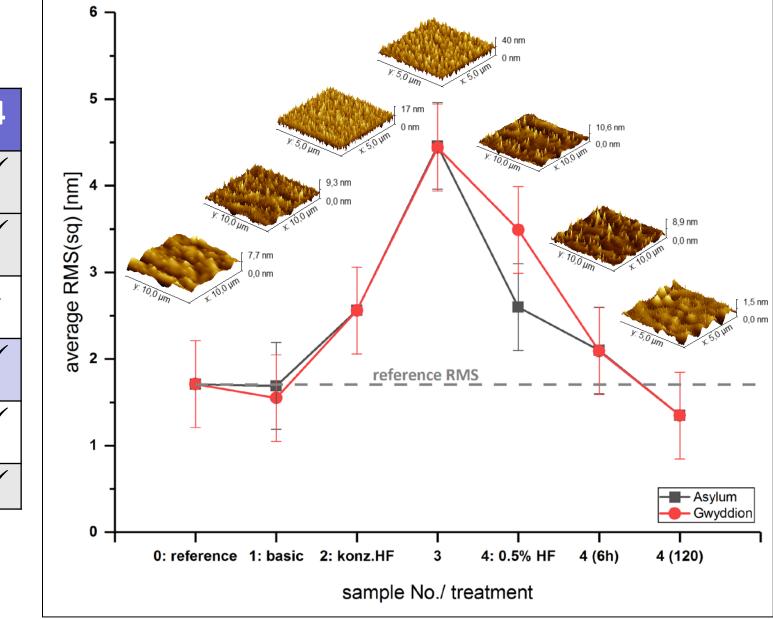


710°C seems suitable for the heat cleaning of GaN. 5% is the best QE in the activation tests on the same sample

## & first cleaning treatments

**Table 2: different wet chemical treating** 

sample No.	1	2	3	4
H <sub>2</sub> SO <sub>4</sub> :H <sub>2</sub> O <sub>2</sub> (1:1), T ~140°C (15 min)		<b>√</b>	✓	<b>√</b>
rinsed 2 x H <sub>2</sub> O		<b>√</b>	✓	<b>√</b>
40% HF (30 s)	-	<b>√</b>	<b>√</b>	-
0.5% HF (2 min)		-	<b>√</b>	<b>√</b>
H <sub>2</sub> O rinsing tank (10 min)		-	<b>√</b>	<b>√</b>
EtOH & Benzol/Isopropanol (3:1) (1 min)		1	<b>✓</b>	<b>√</b>



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